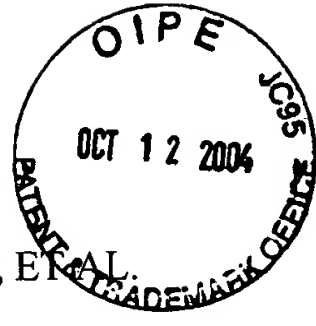


1753
JFW



In re Application of:

Docket No. 03500.015382.

TAKAHARU KONDO, ET AL.

Application No.: 09/866,665

Examiner: Brian L. Mutschler

Filed: May 30, 2001

Group Art Unit: 1753

For: SILICON-TYPE THIN FILM FORMATION
PROCESS, SILICON TYPE THIN FILM,
AND PHOTOVOLTAIC DEVICE

Date: October 8, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.

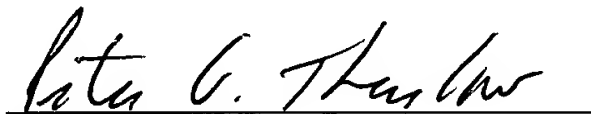
The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 14	MINUS	** 21	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	* 3	MINUS	*** 5	= 0	x \$44 \$88	\$0.00
Fee for Multiple Dependent claims \$150°/\$300						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT—						\$0.00

- * If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.
- ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
- *** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Peter G. Thurlow
Attorney for Applicants
Registration No.: 47,138

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

NY_MAIN 457657v1

03500.015382.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: Brian L. Mutschler
TAKAHARU KONDO, ET AL.)
: Group Art Unit: 1753
Application No.: 09/866,665)
:
Filed: May 30, 2001)
:
For: SILICON-TYPE THIN FILM)
: FORMATION PROCESS, SILICON)
: TYPE THIN FILM, AND)
: PHOTOVOLTAIC DEVICE) October 8, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated July 8, 2004, please amend the
above-identified application as follows. The claim amendments are reflected in the listing
that begins at page 2, and the Remarks begin at page 6.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on October 8, 2004
(Date of Deposit)

Peter G. Thurlow (Reg. No. 47,138)

(Name of Attorney for Applicants)

Peter G. Thurlow

Signature

October 8, 2004

Date of Signature